

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination HOJO ET AL.	
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,133,412	10-2000	Malik et al.	528/425
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Malik et al, "Lithographic properties of novel acetal-derivatized hydroxy styrene polymers", Proceedings of SPIE -- Volume 3678 □ Advances in Resist Technology and Processing XVI, Will Conley, Editor, June 1999, pp. 388-400 :
	V	Iwanaga Shinichiro et al (JP 11-002902) Machine English translation from www19.ipdl.ncipi.go.jp website.
	W	Derwent-Acc-No: 1999-126674 abstract of JP 11002902 A, Derwent Information LTD, 2 pages.
	X	AN 1999:23513 from CAPLUS, ACS on STN, entered STN 12 Jan 1999, English Abstract of JP 11002902.

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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	G	US-			
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	J	US-			
	K	US-			
	L	US-			
	M	US-			

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Tanabe Takyoshi et al (JP 11-030865) Machine English translation from www19.ipdl.ncipi.go.jp website.
	V	Momoto Atsushi et al (JP 2003-307840) Machine English translation from www19.ipdl.ncipi.go.jp website.
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.